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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al.                      Art Unit : 2811  
Serial No. : 10/647,539                                      Examiner : Long Pham  
Filed : August 26, 2003  
Title : SEMICONDUCTOR THIN FILM AND ITS MANUFACTURING METHOD  
AND SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT IN REPLY TO QUAYLE ACTION OF NOVEMBER 3, 2004**

Please amend the above-identified application as follows:

**Amendments to the claims** begin at page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.